



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Hongyong Zhang

Art Unit : 2814

Serial No. : 09/362,808

Examiner : Shrinivas H. Rao

Filed : July 28, 1999

Title : METHOD OF FABRICATING SEMICONDUCTOR DEVICE

MAIL STOP AF

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

AMENDMENT IN REPLY TO ACTION OF APRIL 6, 2005

Please amend the above-identified application as follows:

Amendments to the Claims are reflected in the listing of claims, which begins on page 2 of this paper.

Remarks/Arguments begin on page 12 of this paper.